PTO/SE/084(10-01)
Approved for use through 10/31/2002, OMB 651-2031
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STATEMENT BY APPLICANT	Application Number	10/730,641	
(Use as many sheets as necessary) > 1	Filing Date	December 8, 2003	
MR 0 3 2004 153	First Named Inventor	Farrar, Paul	
	Group Art Unit	2824 2815	
AUG THAT THAT THE	Examiner Name	Owens, Beth	
Sheet 1 of 1	Attorney Docket No: 1	303.041US2	

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EXAMINER John Contraction

DATE CONSIDERED

7/29/4